**PATENT APPLICATION** 

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA et al.

Group Art Unit: 2873

Application No.: 10/645,780

Examiner:

D. Collins

Filed: August 22, 2003

Docket No.:

105198.04

For:

PROJECTION EXPOSURE APPARATUS AND METHOD

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the April 9, 2004 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.